

Notice of References Cited

Application/Control No.

09/327,469

Applicant(s)/Patent Under
Reexamination
YAMAZAKI, SHUNPEI

Examiner

Ginette Peralta

Art Unit

2814

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf, S.; Tauber, R.N..Silicon Processing for the VLSI Era, Volume 1- Process Technology. Lattice Press, 1986. Pp. 63-70.
	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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